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2877

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Elaine C. VonSpreckelsen

CC:**COMPANY:**

US Patent Office

Docket No.

7009/018CP

FAX NUMBER:

1-703-308-7722

PHONE NUMBER:

1-703-308-4808

RE:

Serial No. 09/296,928

TOTAL PGS INCLUDING COVER:

8

URGENTFOR REVIEWPLEASE COMMENTPLEASE REPLY**NOTES/COMMENTS:**

Patent Application of: Cemi et al.
Serial No.: 09/296,298

Docket No.: 7009/018CP
Filed: 22-Apr-1999

Attached is a Request For Reconsideration, Amendment and Remarks (7 pages) FAX COPY RECEIVED

Elaine C. VonSpreckelsen
Secretary to Carl A. Forest

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#14

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.: 09/296,928)	Group Art Unit: 2877
)	
Filed: April 22, 1999)	Examiner: Pham, H.
)	
For: Chemical Mechanical Planarization)	Docket No.: 7009/018CP
(CMP) Slurry Quality Control Process)	
And Particle Size Distribution Measuring)	
Systems)	
)	
Inventors: Cerni et al.)	

CERTIFICATE OF TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that this correspondence, along with all papers referred to as being transmitted, are being facsimile transmitted to Box AF, Assistant Commissioner For Patents, Washington, DC at Patent and Trademark Office Fax No. (703) 308-7722.

March 15, 2001

Date

Elaine C. VonSpreckelsen

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REQUEST FOR RECONSIDERATION

This Amendment and Remarks is responsive to the Office Action mailed February 7, 2001, and includes a summary of a telephone interview with the examiner on March 12, 2001.

AMENDMENT

Please amend claims 1 and 26 as follows:

1. (Twice Amended) A quality control process for detecting physical and/or chemical changes in a CMP slurry, comprising the steps of:

transmitting radiation through a flow of [a] an undiluted optically dense slurry as used in a chemical mechanical planarization (CMP) process, the radiation having one or more wavelengths;

Serial No. 09/296,928

**Amendment and Remarks Responsive to
Office Action Mailed 02/07/01**

Page 1

DOES NOT COMPLY WITH
RULE #37 CFR 1.121
3/20/01